

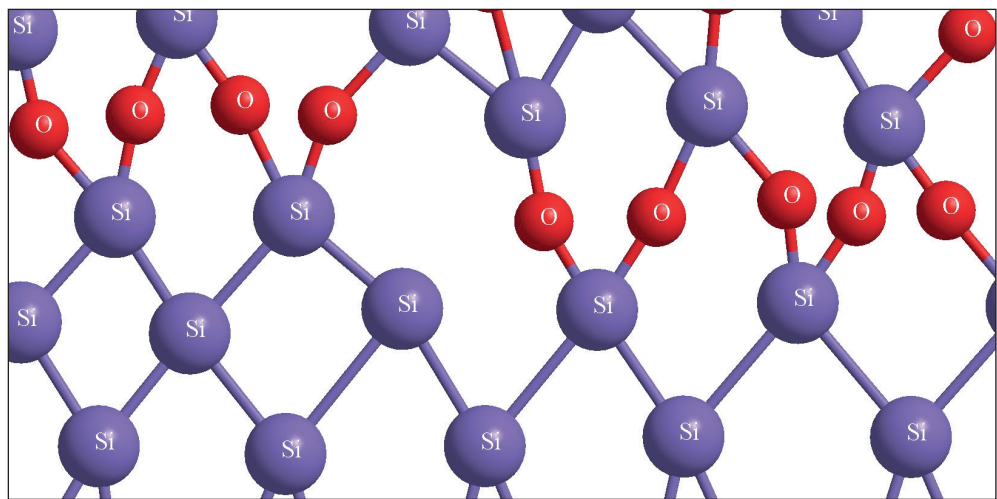


Рис. 4. P_{b0} -центр на границе Si – SiO₂
 Fig. 4. P_{b0} -center at the Si – SiO₂ interface